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EPW:2822
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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuaki HASHIMOTO

Group Art Unit: 2822

Application No.: 09/615,503

Examiner: D. Graybill

Filed: July 13, 2000

Docket No.: 101929.02

For: SEMICONDUCTOR DEVICE, METHOD OF FABRICATING THE SAME, CIRCUIT BOARD, AND ELECTRONIC APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

☒ 1. This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection, Notice of Allowance, or other action that closes prosecution (e.g., Quayle Action), but before payment of the Issue Fee. Attached is our Check No. 163810 in the amount of \$180.00 in payment of the fee under 37 CFR §1.17(p). Please credit or debit Deposit Account No. 15-0461 as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.

☒ a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.
37 CFR §1.97(e)(1).

☒ 2. English language Abstracts of the non-English language references are attached hereto.

☒ 3. A computer-generated English language translation of the following Japanese references has been obtained from the websites of the Japanese Patent Office (<http://www.jpo.go.jp>) and the European Patent Office (<http://www.ep.espacenet.com>),

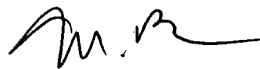
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and is attached, but has not been reviewed for accuracy. See References 1-7.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

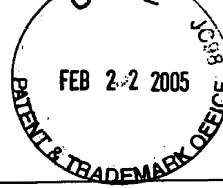
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JAO:MB/kzb

Date: February 22, 2005

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>

Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 101929.02		APPLICATION NO. 09/615,503	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Nobuaki HASHIMOTO			
				FILING DATE July 13, 2000		GROUP 2822	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1	JP 11-176873 w/Abstract and English Translation	07/02/1999	Japan			
	2	JP 10-098073 w/Abstract and English Translation	04/14/1998	Japan			
	3	JP 08-078482 w/Abstract and English Translation	03/22/1996	Japan			
	4	JP 08-031866 w/Abstract and English Translation	02/02/1996	Japan			
	5	JP 11-126854 w/Abstract and English Translation	05/11/1999	Japan			
	6	JP 10-261674 w/Abstract and English Translation	09/29/1998	Japan			
	7	JP 11-087902 w/Abstract and English Translation	03/30/1999	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: February 22, 2005